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10569869 - GAI: 1787

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10569869	
	Filing Date		2006-02-28	
	First Named Inventor	Futoshi Nomura		
	Art Unit	1787		
	Examiner Name	Cheng Yuan Huang		
	Attorney Docket Number	03933.000400.		

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	Attorney Docket Number	03933.000400.		

	3	06-043819	JP		1994-02-18	Nippon Carbide Inc Co Inc		<input type="checkbox"/>
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	5	97/44769	WO		1997-11-27	Minnesota Mining and Manufacturing Company		<input type="checkbox"/>
	6	98/22837	WO		1998-05-28	Minnesota Mining and Manufacturing Company		<input type="checkbox"/>
	7	99/55791	WO		1999-11-04	Minnesota Mining and Manufacturing Company		<input type="checkbox"/>
	8	2000-265012	JP		2000-09-26	Mitsui Chemicals Inc.		<input type="checkbox"/>
	9	1 225 554	EP		2002-07-24	3M Innovative Properties Company		<input type="checkbox"/>
	10	2005-024990	JP		2005-01-27	Nippon Carbide Ind Co Inc		<input type="checkbox"/>
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